



EL979978135

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/071,425
Confirmation No. 1727
Filing Date February 8, 2002
Inventor Terry L. Gilton et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Thanhha S. Pham
Attorney's Docket No. MI22-1828
Customer No. 021567
Title: Semiconductor Processing Method Using Photoresist and an
Antireflective Coating

RESPONSE TO SEPTEMBER 8, 2003 OFFICE ACTION

To: Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA U.S. EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
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Responsive to the Office Action dated September 8, 2003, Applicant
amends and remarks as follows:

11/28/2003 SZEWDIE1 00000086 10071425

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AMENDMENTS

